

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Sakae KOYATA, et al.. Confirmation No.: 3799
Serial No.: 10/562,236 Art Unit: 1792
Filed: February 7, 2007 Examiner: Kin Chan Chen
For: Manufacturing Method of Silicon Wafer Attorney Docket No: JG-SU-5222/Y3079-00108

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

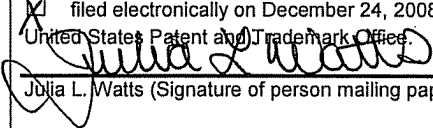
Dear Sir:

Applicant herewith submits this Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §§ 1.97 and 1.98, and hereby make of record the following references:

	Document Number	Date	Country and/or Name	English Translation or Equivalent
* **	JP 2003-282491	10/03/2003	Japan – Sumitomo Mitsubishi Silicon	yes
* **	US 2005/112893	05/26/2005	US – Koyata, et al.	yes
* ** ***	US 5 963 821	10/05/1999	US – Kai, et al.	yes
*	EP 1 313 135	05/21/2003	EPO – Shin-Etsu Handotai Co., Ltd.	yes
	JP 11-233485	08/27/1999	Japan - Shin-Etsu Handotai Co., Ltd.	yes

CERTIFICATE OF MAILING UNDER 37 C.F.R §1.8(a)

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being

MAILED	ELECTRONIC FILING
<input type="checkbox"/> deposited with the United States Postal Service on December 24, 2008 with sufficient postage as EXPRESS MAIL LABEL NO in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	<input checked="" type="checkbox"/> filed electronically on December 24, 2008 with the United States Patent and Trademark Office.
_____ Julia L. Watts (Signature of person mailing paper)	 _____ Julia L. Watts (Signature of person mailing paper)

Accompanying this Information Disclosure Statement and Form PTO-1449 are copies of the documents including English language abstract, if any.

The references noted above with an asterisk ("*") have been cited in the European Search Report, references noted above with two asterisks ("**") have been cited in the Office Action by the EPO, references noted above with three asterisks ("***") have been cited in the Office Action by the Chinese Patent Office. Copies of these Reports are attached hereto for reference.

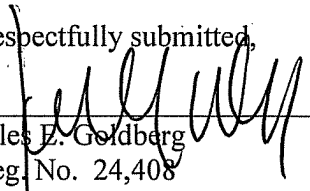
The USPTO waived the requirement under 37 C.F.R. §1.98(a)(2)(i) for submitting of copies of U.S. patents and U.S. patent application publications in all U.S. applications filed after June 30, 2003.

This Information Disclosure Statement is filed under 37 C.F.R. § 1.97(b), before the mailing of a first Office Action on the merits. Therefore, Applicants do not believe that any fees are due. If the Commissioner determines that a fee is required, the Office is hereby authorized to charge said fee to and any other fees that may be due to Duane Morris LLP Deposit Account No. 04-1679.

No admission is made that the information cited in this Statement is, or is considered to be, material to patentability and no representation is made that a search has been made. 37 C.F.R. §§1.97(g) and (h).

Dated: December 24, 2008

Respectfully submitted,



Jules E. Goldberg
Reg. No. 24,408
Attorney for Applicants
DUANE MORRIS LLP
1540 Broadway
New York, New York 10036
212-692-1000

JEG:jlw